



Mark Boland

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September 25, 2003



## MAIL STOP PATENT APPLICATION

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Re:

Application of Fumiyuki NISHIYAMA, Kenichiro SATO and Kunihiko

KODAMA

POSITIVE RESIST COMPOSITION AND PATTERN FORMATION

METHOD USING THE SAME

Assignee: FUJI PHOTO FILM CO., LTD.

Our Ref. Q77490

Dear Sir:

Attached hereto is the application identified above comprising one hundred forty five (145) sheets of the specification, including the claims and abstract, a copy of an executed Assignment and PTO 1595 form, and a copy of an executed Declaration and Power of Attorney. Also enclosed is an Information Disclosure Statement and PTO/SB/08 A & B (modified).

The Government filing fee is calculated as follows:

Total claims	14 - 20	=	X	\$18.00	=	\$.00
Independent claims	1 - 3	=	x	\$84.00	=	\$.00
Base Fee						\$750.00
TOTAL FILING FEE						\$750.00
Recordation of Assignment						\$40.00
TOTAL FEE						\$790.00

Checks for the statutory filing fee of \$750.00 and Assignment recordation fee of \$40.00 are attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this transmittal letter is attached.



## MAIL STOP PATENT APPLICATION September 25, 2003 Page 2

Priority is claimed from:

Country

Application No

Filing Date

September 30, 2002

2002-287252

September 30, 2002

September 30, 2002

2002-287393

September 30, 2002

La leg. 33,102

The priority documents will be filed at a later date.

Respectfully submitted, SUGHRUE MION, PLLC

Attorneys for Applicant

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